RECEIVED CENTRAL FAX CENTER

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.:

10/647,714

Conf. No.:

2476

MAY 2 5 2004

Filing Date: 08/25/2003

Art Unit:

2818

Applicant:

Khan et al.

Examiner:

Le, Thao P.

Title:

METAL OXIDE SEMICONDUCTOR

Docket No.:

SETI-0002DIV

HETEROSTRUCTURE FIELD EFFECT TRANSISTOR

## COMMISSIONER FOR PATENTS

DESTINATION PHONE NUMBER:

703-872-9306

Transmitted herewith is:

Amendment in 11 pages

in the above identified application.

- No additional fee is required.
- The Commissioner is hereby authorized to charge and credit Deposit Account No. 500999 as  $\boxtimes$ described below.
  - Credit any overpayment. Ø

Charge any additional fee required.  $\mathbf{X}$ 

John W. LaBatt, Reg. No. 48,301

DATE: May 25, 2004

## CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office

John LaBert (Person transmitting this correspondence)

Signature

FC:2202

If you receive this correspondence in error or do not receive the entire transmission, please notify us at (518) 449-0044.

PAGE 1/12 \* RCVD AT 5/25/2004 9:58:41 AM [Eastern Daylight Time] \* SVR:USPTO-EFXRF-1/3 \* DNIS:8729306 \* CSID:518 449 0047 \* DURATION (mm-ss):04-38